Nucleation and Growth of GaN/AIN Quantum Dots

C.Adelmann and B.Daudin

CEA/CNRS Research G roup \N anophysique et Sem iconducteurs", Departement de Recherche Fondamentale sur la Matiere Condensee, CEA/Grenoble, 17 Rue des Martyrs, 38054 Grenoble Cedex 9, France

R.A.Oliver^y and G.A.D.Briggs

D epartm ent of M aterials, University of Oxford, Parks Road, Oxford OX1 3PH, United K ingdom

R.E.Rudd

Law rence Liverm ore National Laboratory, 7000 East Avenue, Liverm ore, California 94550, USA

W e study the nucleation of G aN islands grown by plasm a-assisted molecular-beam epitaxy on A N (0001) in a Stranski-K rastanov mode. In particular, we assess the variation of their height and density as a function of G aN coverage. We show that the G aN growth passes four stages: initially, the growth is layer-by-layer; subsequently, two-dimensional precursor islands form, which transform into genuine three-dimensional islands. During the latter stage, island height and density increase with G aN coverage until the density saturates. During further G aN growth, the density remains constant and a bim odal height distribution appears. The variation of island height and density as a function of substrate temperature is discussed in the framework of an equilibrium model for Stranski-K rastanov growth.

I. IN TRODUCTION

Zero-dim ensional sem iconductor quantum dots (QDs) have attracted much interest in the last decade due to their multiple potential applications ranging from low-threshold lasers^{1,2} via single-electron tunneling devices^{3,4} to possible realizations of qubits for quantum computation.^{5,6} A versatile method for the fabrication of sem iconductor QDs is their self-assem bled grow th following the Stranski-K rastanov (SK) growth mode.⁷ This m ode usually occurs during the grow th of sem iconductor epilayers under com pressive strain. Exam ple m aterial systems are $\ln_x Ga_{1x} A s/GaA s_r^{8,9,10}$ Si_x Ge_{1x} /Si_r^{11,12} CdSe/ZnSe,¹³ or GaN/AN.^{14,15} In this mode, atom s are initially deposited in form of a two-dimensional pseudom orphic wetting layer. The associated strain energy increases with the thickness of the wetting layer and is nally elastically relieved by the form ation of islands.

The usefulness of such self-assembled nanostructures relies on the ability to obtain hom ogeneous size distributions as well as to control their size, density and position. M any theoretical contributions have enhanced our understanding of the size distributions of SK -grown islands, but some controversy remains.^{16,17,18,19,20,21,22} A lso, despite m any experimental studies, the in uence of grow th parameters on the size and density of such islands is not fully understood, ow ing to the com plexity of the physics of strained layer grow th.

In this work, we present results on the nucleation of G aN islands on A \mathbb{N} following an SK mode, in particular on the dependence on the amount of deposited G aN and the substrate tem perature. We nd that the qualitative behavior is similar to that found in other systems, e.g. for InA s/G aA s and G e/Si. This reinforces the idea that there are common features of semiconductor SK growth,

which are rather universal and independent of the speci c m aterial system. Absolute island sizes then densities will depend on the m aterial system, possibly through m aterial parameters like lattice m is t, elastic constants, or surface energies. Hence, we may further discuss the experimental data in the framework of an equilibrium m odelbased on statistical physics that was originally developed in work on the G e/Si system.²³

II. EXPERIMENTAL

The samples have been grown in a MECA 2000 molecular-beam epitaxy (MBE) chamber equipped with standard e usion cells for G a and Al evaporation. The chamber also contains an rf plasm a cell to provide active nitrogen for G aN and A N growth. The pseudo-substrates used were about 2 m thick G aN (0001) (G apolarity) layers grown by metal-organic chemical vapor deposition on sapphire. The substrate temperature T_S was measured by a therm occuple in mechanical contact to the backside of the molybdenum sample holder. To ensure substrate temperature reproducibility, each series of sam ples described below was grown on a single molybdenum substrate holder.

P rior to all experiments, a 100 nm thick G aN layerwas grown under Ga-rich conditions on the pseudosubstrates to avoid the in uence of a possible surface contamination layer. Subsequently, a 300 nm thick A N Im was deposited under A l-rich conditions at a substrate tem – perature of 730 C. We have found by rejection highenergy electron di raction (RHEED) and high-resolution X-Ray di raction that this thickness is su cient for the A N layer to be virtually fully relaxed with a residual inplane strain of $_1 < 0.1$ %.²⁴ An atom ic-force m icroscopy (AFM) im age of such an A N (0001) surface is shown

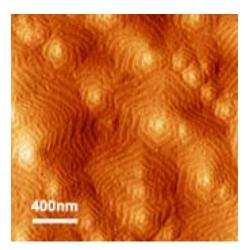


FIG.1: A tom ic-force m icrograph of an A N pseudosubstrate.

in Fig. 1. The surface is characterized by about 30 nm wide terraces and spiralhilbocks, similar to G aN surfaces grown under equivalent conditions.²⁵

The growth rate and the GaN coverage have been experim entally determ ined for each sam ple by RHEED oscillations occurring during the grow th of the wetting layer prior to island form ation.²⁶ Typically, grow th rates for di erent layers (and di erent sam ples) were reproducible within about 0.01m onolayers (ML)/s. The GaN coverage was then calculated with a precision better than 0.1 M L. It is worth noting that no measurable in uence of the growth rate on GaN island properties has been found in the range between 0.1 and 0.6M L/s. As, on the other hand, the Ga/N ux ratio has been found to have a crucial in uence on the growth mode,²⁶ it was xed to 0.8(N -rich conditions), which leads to a critical thickness for the SK transition of 2.25M L.^{26,27} The critical thickness was measured for each sample and found to be reproducible within 0.1ML.

To study the G aN islands as grown, the sam ples were rapidly quenched to room temperature under an N-ux. Ex-situ AFM was then used to study the G aN m orphology after exposure of the sam ples to air.

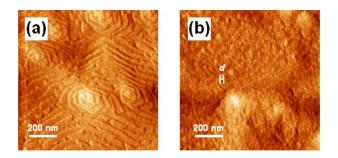


FIG. 2: A tom ic-force m icrograph of the G aN surface m orphology for coverages of (a) $1.8 \,\text{ML}$ and (b) $2.2 \,\text{ML}$, respectively. In (b), d 20 nm indicates the typical lateral length scale of the 2D precursor islands.

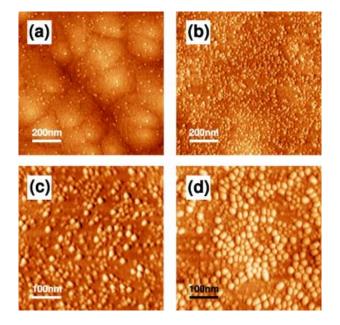


FIG.3: A tom ic-force m icrograph of G aN surface m orphology for coverages of (a) 2.5 M L, (b) 2.8 M L, (c) 3.0 M L, and (d) 4.6 M L, respectively.

III. RESULTS

A. Dependence on GaN coverage

The parameter most directly governing the properties of G aN islands grown in an SK mode on A N is the G aN coverage , which e ectively describes the time evolution of the islands during growth. To study this evolution, a series of samples has been grown at a substrate temperature of 730 C and a growth rate of 0.15 M L/s. The G aN coverage was varied between = 1.8 M L and = 4.6 M L.

Figure 2(a) shows an AFM in age of the morphology of GaN layers obtained after the deposition of $1.8 \,\mathrm{M}$ L, i.e. for a coverage well below the critical thickness of $2.25 \,\mathrm{M}$ L.W e nd that them orphology is unchanged with respect to that of the A N pseudosubstrate: the surface is characterized by about 30 nm wide terraces and spiral hillocks. We can thus infer that the grow th of about the rst 2M L of GaN occurs in a layer-by-layer mode since RHEED oscillations are observed.²⁶

W hen the second monolayer is completed, the morphology changes, as evidenced in Fig. 2 (b) for = 22M L, i.e. immediately before the SK transition. Remainders of terraces and spiral hillocks are still visible, but the surface is characterized on a short scale by $1\{2M L \text{ high at } 2D \text{ islands with typical diameters of } d 20 \text{ nm} (see Fig. 2 (b)). The behavior can thus be described by a transition from a layer-by-layer grow th to multilayer grow th at around <math>2.0M L$. Such an occurrence of 2D precursor islands prior to the genuine 2D -3D SK transition has also been observed in the InA s/ (A LG a)As

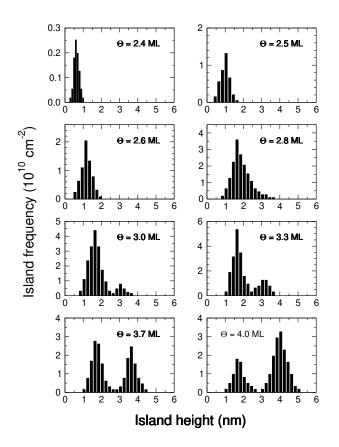


FIG.4: Height distribution of GaN islands grown on A IN with nom inal coverages as indicated. $T_{\rm S}$ = 730 C.

system .28,29,30,31

W hen the growth is continued, the genuine 2D-3D transition occurs and 3D G aN islands are formed as shown in Fig. 3. We nd that their density increases strongly with G aN coverage and saturates around 3.0M L at a value of 1.8 10^{11} cm² [see Figs. 3 (a) and (b)]. Further G aN deposition does not lead to an increase in island density but instead islands grow in size. How ever, the islands do not grow continuously in size but a bim odal size distribution is observed [see Figs. 3 (c) and (d)].

The variation of the island size is sum marized in Figs.4 and 5. We see that, initially, the islands' height increases from 0.7 nm to 1.6 nm between 2.4 and 2.8 M L of G aN coverage. For higher G aN coverage, a bim odal size distribution is observed with the average height of the rst m ode islands remaining constant at 1.6 nm independent of coverage. In contrast, the average height corresponding to the second m ode increases continuously reaching 4.2 nm at 4.7 M L coverage with no sign of saturation in the exam ined coverage range. D i erences in the shapes of m ode 1 and m ode 2 islands will be discussed below.

The variation of the island density is depicted in Fig.6. We observe that the total density increases strongly after the 2D {3D transition but saturates after 2.8 M L, i.e. at the coverage where the island size distribution becomes bim odal. The partial densities of the two modes are shown in the inset in Fig.6. For coverages below 2.8 M L,

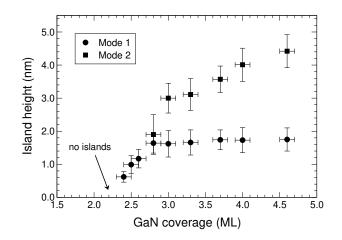


FIG.5: A verage island height as a function of G aN coverage at $T_{\rm S}$ = 730 C.Above 2.8ML a bim odal size distribution is observed.

the density of mode 1 islands is identical with the total density and increases strongly with coverage. A fter the deposition of 2.8M L, the density of mode 2 islands increases strongly, similarly to the behavior of mode 1 islands after the 2D {3D transition, whilst the density of mode 1 islands decreases. As the total island density remains approximately constant, mode 1 islands transform into mode 2 islands, probably without additional nucleation of new (mode 1) islands.

B. Dependence on substrate tem perature

The in uence of the substrate temperature is studied in a series of samples with = 3.0 M L deposited at substrate temperatures between $T_S = 690 \text{ C}$ and $T_S = 760 \text{ C}$. At low ertem peratures, no SK grow th is ob-

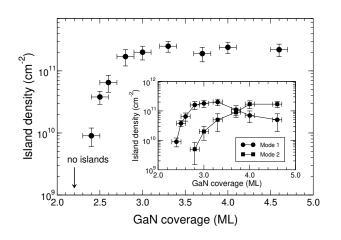


FIG. 6: Total GaN island density as a function of GaN coverage at $T_{\rm S}$ = 730 C.The inset shows the partial density of the islands in the two modes. We observe that mode 1 islands transform into mode 2 islands after the deposition of about 2.8 { 3.0 M L.

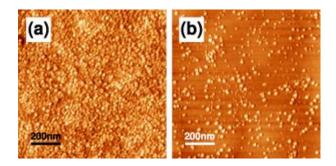


FIG .7: A tom ic-force m icrograph of G aN surface m orphology as a function of substrate tem perature: (a) $T_{\rm S}$ = 700 C; (a) $T_{\rm S}$ = 760 C.

served and G aN grows in a pseudo-2D m ode, 14,26,27 probably due to excessively low adatom mobility. ³² Higher substrate tem peratures are prohibited by our experimental apparatus due to indiam bonding of the substrates to the substrate holder. All samples in this series were grown at a growth rate of 0.25M L/s.

An AFM image of the morphology of two G aN layers grown at substrate temperatures of $T_{\rm S}$ = 700 C and $T_{\rm S}$ = 760 C, respectively, are shown in Fig. 7. We observe that the total island density decreases rapidly with substrate temperature, in keeping with previous results^{15} and also with results obtained for the InA s/G aA s^{33} and G e/Si^{34} system s. The variation of the G aN island density as a function of substrate temperature for a coverage of = 3:0 M L is depicted in Fig. 8. We nd an approximately exponential decrease of the island density with increasing substrate temperature from 4:1 10^{11} cm 2 at $T_{\rm S}$ = 690 C to 8:0 10^{10} cm 2 at $T_{\rm S}$ = 760 C.

As we have seen above, the island density tends to saturate at su ciently high G aN coverage. This saturation density is shown as a function of substrate tem perature in the inset in Fig. 8. For substrate tem peratures

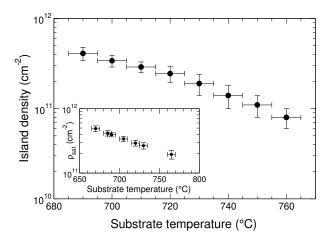


FIG.8: GaN island density for a coverage of = $3.0 \,\mathrm{M\,L}$ as a function of substrate tem perature $T_{\rm S}$. The inset shows the island saturation density as a function of substrate tem – perature.

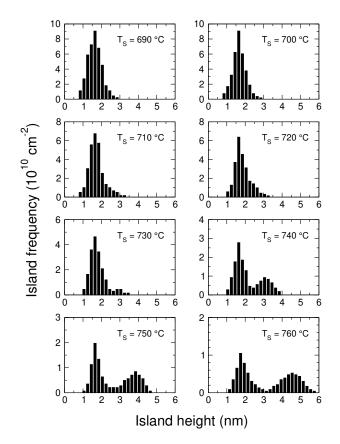


FIG.9: Height distribution of G aN islands grown on A \mathbb{N} at substrate tem peratures as indicated. = 3:0 M L.

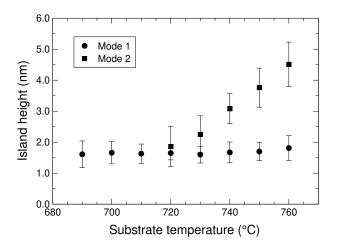


FIG.10: A verage island height as a function of substrate tem perature for a G aN coverage of = 3.0 M L. A bove 720 C a bin odal size distribution is observed.

of T_S 730 C, the saturation density is similar to the density for = 3.0 M L, in agreement with the results in the last section. However, for higher substrate temperature, the saturation density is significantly higher, indicating that saturation occurs for G aN coverages larger than 3.0 M L.

Figure 9 shows the island height distribution for =

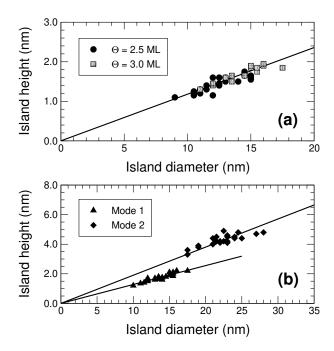


FIG.11: (a) Island height as a function of diam eter for m ode 1 islands obtained for two G aN coverages, as indicated. $T_S = 730$ C. The solid line corresponds to an aspect ratio of = 0.12. (b) Island height as a function of diam eter for m ode 1 and m ode 2 islands. $T_S = 730$ C, = 4.0 M L. The solid lines correspond to aspect ratios of = 0.13 for m ode 1 and = 0.19 for m ode 2, respectively.

3:0M L and substrate temperatures as indicated. The behavior is sum marized in Fig. 10. We nd a single approximately Gaussian distribution (in the limit of the statistical precision) at a height of 1.6 nm for substrate tem peratures T_S 720 C. These islands correspond to the mode 1 islands observed at $T_S = 730$ C and discussed above. At low temperature, the distribution is thus still m onom odal after 3.0 M L. For $T_S = 730$ C, a shoulder appears at the high island side of the distribution and transform s into a clearly separated second m ode at higher tem peratures. Hence, we nd that bim odal distributions occur earlier (for lower GaN coverage) at higher substrate tem perature. A nother rem arkable nding is that the height of the mode 1 islands remains constant as a function of tem perature, whereas the height of m ode 2 islands increases with tem perature, again without signs of saturation in the exam ined tem perature range.

C. D iscussion

The above results demonstrate the occurrence of bimodal island size distributions at high GaN coverage and/or substrate temperature; at low GaN coverage and/or substrate temperature, the size distribution is monomodal. Remarkably, when bimodal distributions occur, the size of mode 1 islands (sm aller islands) appears independent of growth parameters such as GaN

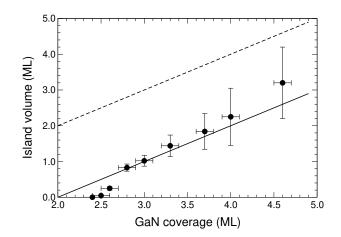


FIG.12: Total volume contained in 3D GaN islands as a function of coverage. The solid line indicates the expected behavior for a constant 2M L thick wetting layer, whereas the dashed line indicates the expected behavior for no wetting layer at all.

coverage and substrate tem perature.

As discussed above, the variation of partial densities of both modes im plies that rst mode 1 islands are nucleated, their density saturates and the grow th proceeds further by transform ation of m ode 1 islands into m ode 2 islands. Thus the question arises, whether this transform ation involves a shape change of the islands sim ilar to the behavior observed in the Ge/Sisystem, where pyram idal islands are observed to transform into \dom e"-shaped islands during grow th.^{18,35} Som e inform ation about the island shape can be gathered by RHEED. The RHEED im ages corresponding to pure m ode 1 island m orphologies and morphologies with a mixture of mode 1 and mode 2 islands (but with a majority of mode 2 islands) are both characterized by the same f1013g facets, showing a six-fold rotation symmetry. It thus appears that both types of islands are (truncated) hexagonal pyram ids with f1013g sidew alls, in agreem ent with previous results.^{14,15} However, it is clear that the shape of such islands cannot be obtained from the RHEED pattern alone and further work is necessary to determ ine the precise shape of both types of islands.

A more detailed analysis can be done by extracting the aspect ratio of the islands from the AFM data. Figure 11 (a) depicts the aspect ratio of mode 1 islands for two di erent G aN coverages (at which monomodalheight distributions are observed) at a substrate temperature of 730 C. In spite of the absolute increase of the islands' size, their aspect ratio remains constant and we nd = 0:12. As shown in Fig. 11 (b), the aspect ratio of mode 1 islands remains constant (= 0:13) after the transition to a bim odal distribution but the mode 2 islands have a signi cantly larger aspect ratio of = 0:19. Both aspect ratios correspond to truncated pyramids³⁶ but mode 1 islands are atter.

From the aspect ratio data, we can further calculate the am ount of G aN contained in the 3D islands as a function ofdeposited G aN . The result is shown in Fig.12. We nd that the data are consistent with a 2M L thick wetting layer, independent of the am ount of deposited G aN . It thus appears that in this system, the wetting layer is stable and does not contribute to island growth. The deviation for G aN coverages just after the critical thickness of 2.25M L can be explained by the presence of 2D precursor islands, which still contain signi cant m aterial but are not taken into account as 3D islands.

IV. MODELING

In order to understand more precisely why the observed island distributions form, we analyze the nitride nanostructure grow th in term s of a therm odynam ic equilibrium model that has so far only been applied extensively to the Ge/Si system .²³ To date, little e ort has been made to t data on size distributions of nitride nanostructures to any model. Naka jim a et al.37 have undertaken a purely theoretical study and explicitly derived thickness-com position phase diagram s for the expected growth mode for GaInN/GaN and GaInN/AN, using known materials parameters. However they did not take into account the shapes and sizes of experim entally observed nitride nanostructures, nor did they seek to predict size distributions. Here we take a rather di erent approach. W e apply the therm odynam icm odel to the AFM data on nitride nanostructure distributions grown at one particular tem perature in order to assess whether the bim odal distributions of nanostructures are consistent with therm odynam ic equilibrium, as opposed to being con gurations along an unstable ripening trajectory. The experim ental distributions are described reasonably wellby them odel, as explained below. We then apply the m odel to understand the variations in the bim odal distributions with grow th tem perature at xed coverage, and again nd reasonable agreem ent over a range of grow th tem peratures.

The therm odynam ic equilibrium model makes explicit predictions for the form of the bin odal epitaxial nanostructure distributions. The model is governed by a set of parameters that describes the size dependence of the internal energy of an epitaxial nanostructure. Following Shchukin et al.,¹⁶ we describe the internal energy _i of the ith individual island of type X and volum e _i as follows:

$$i = A_X i + B_X i^{2=3} + C_X i^{1=3} + D_X$$
: (1)

U sing this expression for the internal energy, the island size distribution f ($_{\rm i})$ is given by

$$f(i) = \exp \frac{i}{k_B} T_S$$
 (2)

where is the chemical potential and $k_{B}\,$ is Boltzm ann's constant.

Equation (1) describes the chem ical and elastic contributions to the island energy. The rst term arises from bulk strain, the second from surface and interfacial energies and island-island interactions, and the third from surface stress and edge energies (suppressing the log dependence of the edge elastic relaxation energy). The equation also includes a size-independent term that is relevant only insofar as it di ers from one nanostructure type to another. For the internal energy (1), a minimum may exist if B and C have opposite signs. There has been som e debate over which of the two constants is likely to be positive and which negative. In the initial developm ent of a \shape-m ap" for the bim odal Ge/Si system by W illiam s et al. B was assumed to be negative and C positive. In more recent work on Ge/Si, Rudd et al.²³ have suggested that B should be positive, since a Ge(001) surface does not spontaneously roughen, though they also acknow ledge that, since 3D growth is preceded by the appearance of increasing num bers of defects in the wetting layer with their own associated energy, the behaviour of the Ge (001) surface of a bulk crystalm ay not be relevant and B could be negative. Here, we nd that the option most consistent with the nanostructure size distributions observed by AFM is B > 0 and C < 0.

Unlike in the most recent developm ents of the equilibrium model,²³ we have not, as yet, explicitly included the e ects of the elastic interaction between pairs of islands. W e also have not undertaken a self-consistent calculation of the chem ical potential. Instead, we have taken a sim ilar approach to W illiam s et al.¹⁸ U sing the expressions for the distributions (2) and internal energies (1), we have tted the model to the available data at several coverages and tem peratures, in order to determ ine approximately how the constants A^0 , B, C, and D vary as a function of grow th param eters. For convenience, we have introduced $A^0 = A$. We then used our empirical functions to t the model across multiple data sets, to determ ine how well it compares with the overall behaviour of the system. By comparison with the more sophisticated work of Rudd et al²³ on Ge/Si, we expect B to be dependent on the coverage and A⁰ to depend on the chem ical potential, a non-trivial function of coverage and tem perature.

A. Evolution of size distribution with coverage

In investigating the variation of the param eters A⁰, B, C, and D as a function of coverage, we found that C and D could be treated as being independent of coverage, but that B increased m onotonically with increasing coverage. This coverage dependence is consistent with elastic island-island interactions, which are expected to scale with $_{i}^{2=3}$, and which will increase with increasing coverage. B () could be approxim ated to a straight line with non-zero slope for both the smaller (S) and the larger (L) island types. Thus (for X 2 fS;Lg):

$$B_X$$
 () $B_{0X} + b_X$: (3)

Sim ilarly, W illiam s et al.¹⁸ found that, for the G e/Si case, C was independent of coverage and B varied linearly with coverage. However, they were also able to approxim ate the variation of A^0 with coverage as a straight line with non-zero slope. This does not appear to be valid in this case, and we have not found a simple functional relationship between A^0 and coverage. Hence in thing the m odel across multiple data sets we have calculated a separate value of A^0 for each data set, but have assumed a constant relationship between the value of A^0 for the larger and sm aller islands. E ssentially:

$$A_{L}^{0}() = g()$$
 and $A_{S}^{0}() = g() + A_{0};$ (4)

where $A_0 = A_S \quad A_L$, representing the intrinsic di erences in bulk elastic energy between the two island types. The function g(), which has not been found explicitly, represents the coverage dependence of the chemical potential.

Hence, in thing across four coverages at which large and sm all islands coexist, we used the param eters B $_{
m OS}$, $B_{\,0\rm L}$, $b_{\rm S}$, $b_{\rm L}$, C $_{\rm S}$, C $_{\rm L}$, D $_{\rm S}$, D $_{\rm L}$, A $_0$, and four separately tted values of g(). This clearly gives us a large num ber of parameters however, the model must ta large num ber of observable features of the data. W e are able to provide a reasonable t for each shape for the relative height, position, width and skewness of the volume distributions (essentially 15 experim ental observables for each island shape). Example ts are shown in Fig. 13. The thing has been done using a 2 approach and the goodness-of-tmay be judged by calculating an overall Q -value across the data sets, Q $_{\rm total}.$ For the data sets under consideration, $Q_{total} = 0.22$. Since the available data sets are much smaller for this system than for the Ge/Si system (in which counting large num bers of islands is facilitated by the larger sizes of the islands, and the clear shape di erence between island types) this Q-value is satisfactory. For comparison we have also attempted to t the data with the original model of W illiam set al, 1^{18} and with som e G aussian functions. These ts were markedly worse and it was not possible to nd parameters that t the entire set of data with a reasonable Q -value. From these ndings we may infer that the data are consistent with the equilibrium model; however, the model can in no way be said to have been proven. The model contains a large number of parameters for which little a priori information is available in the nitride systems, and the measured island distributions would bene t from more data in order to reduce the statistical uncertainty. Hence, the discussion that follows is som ew hat tentative.

U sing the calculated param eters we can plot the internal free energy versus volum e curves for both the sm aller and the larger islands. The results are shown in Fig. 14 for three di erent coverages. There is a signi cant evolution of the curves as the coverage increases. Sim ilar

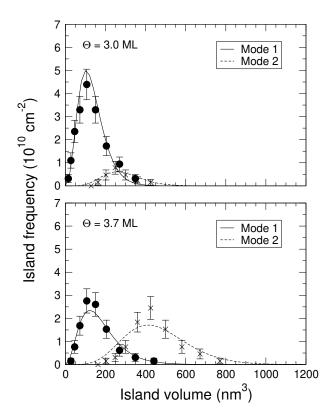


FIG.13: C om parison of experim entally observed island size distributions at 730 C with tted island size distributions for both the smaller (circles) and larger (crosses) islands, for coverages of 3.0 M L and 3.7 M L, as indicated. The tting has been done, as described in the text, with a single set of parameters to describe a range of coverages. Values of the C – and D –parameters do not vary with coverage, values of the B –parameters vary linearly with coverage and values of the A –parameter are individually tted such that $A_{\rm S}$ $A_{\rm L} = A_0$ for all coverages.

results were observed by W illiam s et al.¹⁸ for the evolution of internal energy with coverage in the Ge/Sisystem, and were attributed to the interactions of the nanocrystals. The value of B () a ects the width of the curve and the horizontal position of the energy m in im um . In the Ge/Sicase, W illiam set al. found that for the larger islands (domes) the value of B () increases (becomes less negative) with increasing coverage, whilst the value of B () for the smaller islands (pyramids) decreases, which suggested that the repulsion between domes was stronger than the repulsion between pyram ids. In contrast, the work of Rudd et al.²³ (also on Ge/Si) suggests that B () increases with increasing coverage at a similar rate for both pyram ids and dom es. Sim ilarly, in the current case, we nd that the B-parameter increases with increasing coverage at alm ost the sam e rate for both island types, indicating no signi cant di erence between the elastic island-island interactions for each island type.

Changes in A⁰() tend to shift the internal-free energy versus volum e curves vertically. At low coverages, the minimum internal energy is lower for the smaller is-

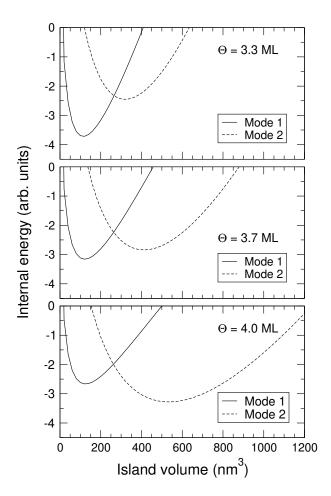


FIG.14: Plots of the variation in internal energy of an island with island volum e for the smaller (solid line) and larger (dashed line) islands at 730 C for three coverages, as indicated.

lands, but at high coverages, it is lower for the larger islands. Hence the form ation of large islands rather than small islands is preferred at high coverages. However, the elastic interactions between islands may mean that not all small islands grow to become large islands. Some may be destabilized by neighbouring islands and dissolve. One surprising feature of the ts is that A^0 is found to be positive for the larger islands, for all coverages. Since the bulk elastic energy is expected to decrease when an island is form ed, this suggests that the chem ical potential is negative and relatively large (since $A^0 = A$). This nding is not yet well understood.

B. Evolution of size distribution with tem perature

In order to understand the variation of the size distribution with tem perature, we must consider the tem perature dependence of the free energy of each island type. In principle, A^0 , B, and C m ay all be tem perature dependent. The size-independent D -parameter is constant and is found to be the same for both sm all and large islands. W illiam s et al.¹⁸ perform ed som e lim ited studies on the tem perature dependence of the tting param eters in Ge/Si and found that only A^0 exhibited signi cant tem perature dependence. Sim ilarly, in this case, C is found to be essentially independent of tem perature. However, for both island types, we have found that B exhibits a signi cant tem perature dependence, such that for X 2 fS;Lg:

$$B_X (T_S) = B_{1X} + _X T_S$$
: (5)

The B-parameter increases at a similar rate for the larger and the smaller islands, im plying that the surface energy contribution from each island type varies in a sim – ilar way with temperature. This is congruent with the suggestion that the fl013g facets seen in RHEED dom – inate both island types. These results are not, how ever, incompatible with the existence of other facets on the larger island types.

The A⁰-parameter, which was found to exhibit a com – plex dependence on coverage, also exhibits a com plex dependence on temperature. Hence in thing the model across a range of temperatures, we have calculated values of A⁰ individually for each data set, but have assumed a constant relationship between the value of A⁰ for the large islands and the value of A⁰ for the sm all islands, such that

$$A_{L}^{0}(T_{S}) = h(T_{S})$$
 and $A_{S}^{0}(T_{S}) = h(T_{S}) + A_{1}$: (6)

For the larger islands, A⁰ is again found to be positive at lower temperatures but decreases smoothly with temperature and changes sign at 755 C. The ts are shown in Fig. 15; Q_{total} = 0:73. The function h (T_S), which has not been found explicitly, includes the tem – perature dependence of the chem ical potential, and any variation in the elastic relaxation with temperature.

This model is only valid if a quasi-equilibrium may be assumed. This assumption is particularly problematic with regards to variation in temperature, since in particular at lower tem peratures, the system may not reach equilibrium, whilst at higher tem peratures signi cant interdi usion between the islands and the substrate may occur. This alloying will e ectively reduce the m ism atch between the islands and the substrate - strongly a ecting the island size distributions, since the mean equilibrium nanostructure volume varies inversely as the sixth power of the mism atch.³⁸ Rudd et al.'s more sophisticated work 23 in creating the nanostructure diagram for the Ge/Si system, could be augmented to account for uniform ly distributed alloying, and for kinetic e ects. In the past, whilst the temperature dependence of the equilibrium island size distribution has been considered theoretically,^{18,23} very little high quality data has been available for comparison. The experimental studies by W illiam s et al.¹⁸ only involved tem peratures of 550 C, 600 C, and 650 C, and there was considerable uncertainty in the tem perature measurement. Additionally,

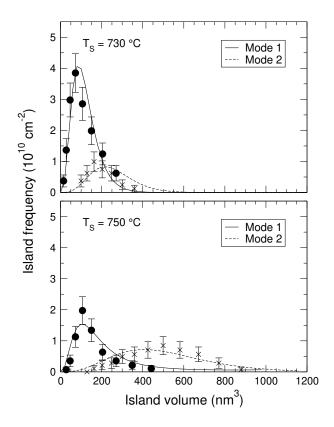


FIG.15: C om parison of experim entally observed island size distributions with tted island size distributions for both the sm aller (circles) and larger (crosses) islands, for a coverage of 3.0 M L and tem peratures 730 C and 750 C, as indicated. The tting has been done, as described in the text, with a single set of parameters to describe a range of tem peratures. Values of the C – and D –parameters do not vary with tem perature, values of the B –parameter vary linearly with tem perature and values of the A –parameter are individually tted such that $A_{\rm S}$ $A_{\rm L} = A_1$ for all coverages.

the sample grown at 550 C is believed to have been signi cantly in uenced by kinetic e ects, and the sam – ple grown at 650 C experienced signi cant interm ixing. Hence the data considered here, relating to a smaller range of more accurately measured temperatures, are very valuable as a rst quantitative test of the temperature dependence of the equilibrium model. In addition, the G an /A IN system presents an important advantage over the G e/Si system since it has been show that alloying is very limited even at high grow th temperatures.³⁹

In considering the results of the tting, we notice that tting across the temperature data sets gives a higher Q_{total} than tting across the coverage data, with an essentially similar tting methodology. One might thus speculate that, since the sam ples used for the coverage data set were grown at the relatively low temperature of 730 C, full equilibrium has not been achieved and kinetic e ects are having some in uence. A worthwhile approach, in investigating this further, will be to exam ine a series of sam ples that have been annealed at grow th tem perature to allow further evolution towards equilibrium .

V. CONCLUSION

Using ex situ AFM, we have studied the evolution of thin GaN layers grown by plasm a-assisted MBE on A N (0001) layers at substrate tem peratures between 700 and 750 C. Initially, 2M L of GaN grow in a 2D mode, followed by the occurrence of 2D islands. These islands act as precursors for 3D islands, which appear after an SK transition around 2.3M L.D uring further growth, in particular at higher tem peratures, a bim odal island size distribution is observed. Remarkably, the size of m ode 1 islands is found to be independent of coverage and tem perature, whereas the size of mode 2 islands increases with coverage and tem perature. The analysis of the partial island densities reveals that, whilst the total island density remains constant, mode 1 islands transform during grow th into m ode 2 islands. The aspect ratio of the islands is measured for both types of islands and it is found that they are characterized by distinctively di erent aspect ratios, whereas no additional facets are observed in the RHEED pattern due to mode 2 islands.

These ndings are examined in the fram ework of an equilibrium model for SK growth. We nd satisfactory agreem ent with the experim ental data, suggesting that, as more data become available, extending the equilibrium approach may be helpful in understanding and tailoring nitride nanostructure distributions. W e have exam ined the variation of each of the tting parameters with growth conditions, and have considered how this m ay relate to the physics of this system . The calculated param eters appear to be compatible with the available data for example the B-parameter, relating to the surface energy of the islands shows a similar variation with grow th param eters for each island type, which is unsurprising if both island types are dom inated by the same facet. However, the ts are in no way perfect, and this may be due to the in uence of kinetic e ects on the island distributions. Further experiments on the annealing of dot arrays at grow th tem perature m ight clarify to what extent the growth proceeds near equilibrium or kinetic e ects are predom inant.

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- ^y Present address: Department of Materials Science and Metallurgy, University of Cambridge, Pembroke Street, Cambridge CB2 3QZ, United Kingdom.
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